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IN THE CLAIMS:

1. (Currently Amended) A thin-sheet mask ~~having a pattern opening, characterized in that comprising:~~

a mask body having a pattern opening; and

a frame.

wherein the said mask body is fixed to [[a]] said frame in a stretched state and said mask body is adhesively bonded in a location coinciding with a line passing through a thermal expansion center in the members of the said frame.

2. (Currently Amended) The mask according to claim 1, ~~characterized in that wherein~~ four corners of said frame have a curvature.

3. (Currently Amended) The mask according to claim 1, ~~characterized in that wherein~~ said mask body is adhesively bonded to the said frame with an adhesive material having heat resistance.

4. (Currently Amended) A thin-sheet mask ~~having a pattern opening, characterized in that comprising:~~

a mask body having a pattern opening; and

a frame.

wherein said the mask body is fixed to [[a]] said frame in a stretched state and said mask body is adhesively bonded in a location on the an outside of a line passing through a thermal expansion center in the members of the said frame,

the said frame is caused to expand by heating during deposition and the said mask body maintains the said stretched state.

5. (Currently Amended) The mask according to claim 4, ~~characterized in that wherein~~ four corners of said frame have a curvature.

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6. (Currently Amended) The mask according to claim 4, ~~characterized in that~~ wherein said mask body is adhesively bonded to ~~the~~ said frame with an adhesive material having heat resistance.

7. (Currently Amended) A container ~~for accommodating a deposition material, which is disposed in a deposition source of a deposition apparatus, characterized in that~~ comprising:
a part for accommodating a deposition material wherein said part for accommodating said deposition material is disposed in a deposition source of a deposition apparatus; and
an opening provided on said part for accommodating said deposition material,
wherein the a cross section in a plane of said container part for accommodating said deposition material has a rectangular or square shape and ~~the~~ said opening ~~portions~~ through which ~~the~~ said deposition material passes has a thin elongated shape.

8.-16. (Canceled)

17. (New) A mask comprising:
a mask body having an opening; and
a mask frame,
wherein a material evaporated from a deposition source is deposited over a substrate through said opening of said mask body, and
wherein said mask body is adhesively bonded to said mask frame in a location coinciding with a line passing through a thermal expansion center of said mask frame.

18. (New) The mask according to claim 17, wherein four corners of said mask frame have a curvature.

19. (New) The mask according to claim 17, wherein said mask body is adhesively bonded to said mask frame with an adhesive material having heat resistance.

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20. (New) A mask comprising:
a mask body having an opening; and
a mask frame,
wherein a material evaporated from a deposition source is deposited over a substrate through said opening of said mask body,
wherein said material comprises an organic compound, and
wherein said mask body is adhesively bonded to said mask frame in a location coinciding with a line passing through a thermal expansion center of said mask frame.
21. (New) The mask according to claim 20, wherein four corners of said mask frame have a curvature.
22. (New) The mask according to claim 20, wherein said mask body is adhesively bonded to said mask frame with an adhesive material having heat resistance.
23. (New) A mask comprising:
a mask body having an opening; and
a mask frame,
wherein a material evaporated from a deposition source is deposited over a substrate through said opening of said mask body,
wherein said mask body is adhesively bonded to said mask frame in a location outside a line passing through a thermal expansion center of said mask frame to fix said mask body to said mask frame in a stretched state, and
wherein said mask frame is caused to expand by heating during the deposition of said material to maintain said stretched state.
24. (New) The mask according to claim 23, wherein four corners of said mask frame have a curvature.
25. (New) The mask according to claim 23, wherein said mask body is adhesively bonded to said mask frame with an adhesive material having heat resistance.

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26. (New) A mask comprising:
a mask body having an opening; and
a mask frame,
wherein a material evaporated from a deposition source is deposited over a substrate through said opening of said mask body,
wherein said material comprises an organic compound,
wherein said mask body is adhesively bonded to said mask frame in a location outside a line passing through a thermal expansion center of said mask frame to fix said mask body to said mask frame in a stretched state, and
wherein said mask frame is caused to expand by heating during the deposition of said material to maintain said stretched state.
27. (New) The mask according to claim 26, wherein four corners of said mask frame have a curvature.
28. (New) The mask according to claim 26, wherein said mask body is adhesively bonded to said mask frame with an adhesive material having heat resistance.

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